

				Type	L #	Hits	Search Text	DBs	Time Stamp	Cor r em en ts	De fi ni ti on	Er ro rs
1	BRS	L1	7				("118"/\$).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:41			

								Co mm en ts	Er ro r De ni ti on	Er ro r De ni ti on
	Type	L #	Hits	Search Text	DBs	Time Stamp				
2	BRS	L2	2	("427"/\$).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:49				

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	Type	L #	Hits	Search Text	DBs	Time Stamp		Co mm en ts	De ni ti on
3	BRS	L3	13	(427/240).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:44			

								Co mm en ts	Er ro r De fi ni ti on	Er ro r De fi ni ti on
	Type	L #	Hits	Search Text	DBs	Time Stamp				
4	BRS	L5	7	("118"/\$).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US-PPGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:43				

								Er ro r Co mm en ts	Er ro r De fi ni ti on
	Type	L #	Hits	Search Text	DBs	Time Stamp			
5	BRS	L6	49	("118"/\$).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:48			

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	Type	L #	Hits	Search Text	DBs	Time Stamp		Co mm en ts	De fi ni ti on
6	BRS	L7	14	(118/52) .ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:44			

		Type	L #	Hits	Search Text	DBs	Time Stamp	Cor ro mm en ts	De fi ni ti on	Er ro rs
7	BRS	L8	2		(118/683).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:45			

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8	BRS	L9	4	(118/684).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:45			

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9	BRS	L10	1	(118/712).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:45			

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10	BRS	L11	12	(118/320).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:45			

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	Type	L #	Hits	Search Text	DBs	Time Stamp				
11	BRS	L12	2	(118/688).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:46				

								Time Stamp	Co mm en ts	Er ro r m De en ni ti on	Er ro r s
	Type	L #	Hits	Search Text	DBs						
12	BRS	L13	1	(118/689).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB		2006/02/16 17:46				

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	Type	L #	Hits	Search Text	DBs	Time Stamp			
13	BRS	L14	0	(118/690).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:46			

				Type	L #	Hits	Search Text	DBs	Time Stamp	Cor r em en ts	De fi ni ti on	Er ro rs
14	BRS	L15	0				(118/691).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:46			

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	Type	L #	Hits	Search Text	DBs	Time Stamp				
15	BRS	L16	4	(118/692).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:46				

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	Type	L #	Hits	Search Text	DBs	Time Stamp			
16	BRS	L17	2	(118/693).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:46			

		Type	L #	Hits	Search Text	DBs	Time Stamp	Cor r em en ts	De fi ni ti on	Er ro r ro rs
17	BRS	L19	39		("438"/\$).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:47			

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	Type	L #	Hits	Search Text	DBs	Time Stamp			
18	BRS	L20	2	("438"/\$).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:47			

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19	BRS	L21	2	(438/780).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:47				

				Type	L #	Hits	Search Text	DBs	Time Stamp	Cor r e ct i on	De fi ni ti on	Er ro rs
20	BRS	L22	0				(438/781).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:48			

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21	BRS	L23	1	(438/758).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US-PPGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:48			

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	Type	L #	Hits	Search Text	DBs	Time Stamp			
22	BRS	L24	0	(438/689).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank	US - PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:48			

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23	BRS	L26	1	((coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve and buffer near tank).clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:49			

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	Type	L #	Hits	Search Text	DBs	Time Stamp				
24	BRS	L25	2	((coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve).clm.	US-PPGUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:49				

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	Type	L #	Hits	Search Text	DBs	Time Stamp			
25	BRS	L18	3	(118/694).ccls. and (coat\$6 or spray\$4 or spin\$4 adj coat\$4) with (substrate or wafer) and pump with tank and (substrate or wafer) with (spin\$4 or rotat\$4) and (fluid or liquid) with (sens\$4 or detect\$5) and valve	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	2006/02/16 17:49			